$M^2 HP - 4 kW$

Advanced High Power Laser Beam Analyzer for CW lasers with built-in Beam Dump





Input Beam

Measuring Method	Knife-edge – 7 blades mounted on a rotating drum
Measuring Parameters	Beam Size, Power, 2D – 3D Beam Profile specific location
Beam Propagation	BPP over up to 50 mm range, M ² and depth of focus
Parameters	along propagation direction
Optional	ND Filters according to application

Scanning Assembly Attachment

Spectral Range	350 - 1100 nm (Si version), IR version available	
Beam Power Range	Up to 4000W (with supplied internal filter)	ł
	Continuous Operating Duration – Limited to 10 seconds @ 2	
	kW and up (Depending on power, see user manual)	
Number of Knife-edges	7	
Beam size	Input diameter- 8 mm max.	
Maximum power	Power density at input aperture- 0.4 kW/mm ²	ł
density	Absolute Maximum Power Density- 2 kW/mm ²	
Minimal work distance	60 mm – distance between input aperture to measuring	

Accuracy:

M² Value: ±10%

Position Accuracy along propagation axis \pm 10 micron Position at the plane perpendicular to propagation \pm 15 micron Resolution: 1 microns

Ordering Information:

M² HP/4 kW BD: The system consists of BA7-Si-USB sensor head with 2.5 m long attached cable, USB 2.0 manifold box, NG4 & NG9 filters in housing, an integral beam sampler, a moving stage 50 mm range, mounting plate, software on CD/DiskOnKey, Air Cooled Beam Dump



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Main Features:

- A unique instrument for measuring high power lasers up to 4 KW
- Laser measurement is possible at the focal point
- Unique beam sampler (samples a fraction of the laser without distortion)
 - M² and BPP real time measurements
 - Built-in air-cooled beam dump

Software Features:

- Real-time M² and BPP measurements of focused beams
- Automatic measurement by a moving stage along 50 mm (Maximum measured beam propagation)
- Data logging and detailed statistics
- ActiveX package to control software from your application
- Detailed analysis of beam selected by the user

